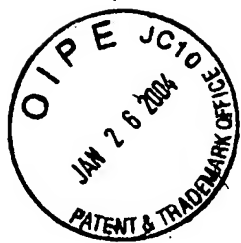


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January 20, 2004

Mail Stop Non-Fee AMENDMENT

Commissioner For Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Re: Applicant(s): Woo Sik Yoo
 Assignee: WaferMasters, Inc.
 Title: Method Of Forming An Oxide Layer (As Amended)
 Serial No.: 10/085,498
 Examiner: Kirsten Jolley
 Docket No.: M-11549 US
 Filed: February 26, 2002
 Group Art Unit: 1762

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter; and
- (3) Response to Notice Non-Compliant Amendment (12 pages).

- ☒ No additional fee is required.
☐ The fee has been calculated as shown below:

CLAIMS AS AMENDED

	Claims Remaining After Amendment		Highest No. Previously Paid For		Present Extra	Rate	Additional Fee
Total Claims	20	Minus	31	=	0	x \$18.00	\$ 0
Independent Claims	2	Minus	5	=	0	x \$84.00	\$ 0
<input type="checkbox"/>	Fee of _____ for the first filing of one or more multiple dependent claims per application						\$
<input type="checkbox"/>	Fee for Request for Extension of Time						\$

Total additional fee for this Amendment:

\$

- ☐ Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.
- ☐ Please charge our Deposit Account No. 50-2257 in the amount of \$
- ☒ Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257

Total: \$0

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450, on January 20, 2004.

Sandy Kim

January 20, 2004

Respectfully submitted,

Theodore P. Lopez
 Attorney for Applicants
 Reg. No. 44,881



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Woo Sik Yoo

Assignee: WaferMasters, Inc.

Title: METHOD OF FORMING AN OXIDE LAYER (As Amended)

Serial No.: 10/085498

Filing Date: February 26, 2002

Examiner: Jolley, Kirsten

Group Art Unit: 1762

Docket No.: M-11549 US

Irvine, California
January 20, 2004

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Dear Sir:

In response to the Notice of Non-Compliant Amendment dated January 15, 2004,
Applicants submit the following amendments and remarks.

IN THE TITLE:

Please replace the current title with the following replacement title:

--METHOD OF FORMING AN OXIDE LAYER--